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On-chip Digital Fourier-Transform Spectrometer Using A Thermo-Optical Michelson Grating Interferometer

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Abstract—This theoretical modeling and simulation paper presents designs and projected performance of an on-chip digital Fourier transform spectrometer using a thermo-optical Michelson grating interferometer operating at ~1550-nm and 2000 nm for silicon-on-insulator and for germanium-on-silicon platforms, respectively. The technological Michelson interferometer arms consist of two unbalanced tunable optical delay lines operating in the reflection mode. They are comprised of a cascade connection of waveguide Bragg grating resonators (WBGRs) separated by a piece of straight waveguide with lengths designed according to the spectrometer resolution requirements. The length of each WBGR is chosen according to the Butterworth filter technique to provide one resonant spectral profile with a bandwidth twice that of the spectrometer bandwidth. A selectable optical path difference (OPD) between the arms is obtained by shifting the notch in the reflectivity spectrum along the wavelength axis by means of a low-power thermo-optical (TO) heater stripe atop the WBGR, inducing an OPD that depends upon the line position of the WBGR affected by TO switching. We examined the device performances in terms of signal recostruction in the radio-frequency (RF) spectrum analysis application at 1 GHz and at 1.5 GHz of spectrometer resolution. The investigation demonstrated that high quality spectrum reconstruction is obtained for both Lorentzian and arbitrary input signals with a bandwidth up to 40 GHz. We also show that spectrum reconstruction of 100 to 200 GHz RF band input signals is feasible in the Ge-on-Si chips.

Index Terms—Bragg grating resonators, Microwave Photonics, True Time Delays, Spectrometer.

I. INTRODUCTION

This theoretical paper proposes and analyzes a new ultrahigh-resolution Michaelson interferometer that functions as an on-chip 64-channel digital Fourier-transform spectrometer (dFTS). The main application investigated here is radio-frequency (RF) spectrum analysis by an integrated optical-microwave system-on-a-chip. For this chip, the light source is a laser "carrier" that is amplitude-modulated by an incoming RF spectrum whose profile is not known. The carrier and both RF sidebands occupy an optical frequency range of about 50 GHz, for example, which calls for at least ~ 1 GHz resolution to determine the RF profile in detail.

An examination of the literature on prior- art on-chip FTS's, shows several recent papers [1-3] that describe a digitally addressed Mach-Zehnder interferometer (dFTS) in which the spectrometer resolution is 0.49 nm within the optical band

centered at 1550 nm. Here we propose an alternative architecture based on this digital approach for high-resolution applications. There is an analogy here to the traditional bulkoptics FTS where an electro-mechanical Michelson interferometer (MI) is employed. Here the MI is a monolithic semiconductor waveguide device that is scanned without moving parts using the thermo-optical (TO) effect. The novelty in the present work consists in several aspects: i) the single MI operates in the reflective mode, giving the needed interferograms via unbalanced MI arms; ii) a selectable optical path difference (OPD) between the arms which is generated using two groups of identical waveguide Bragg-grating resonators (WBGRs) having a peak in transmission and a notch in reflection; iii) only one resonator in each arm is tuned by low-power TO to choose the optical path of each arm; iv) the arm-addressing scheme starts with all gratings in transmission and changes only one to reflection by shifting its profile along the wavelength axis; v) each resonator is a composite of several closely coupled phase-shifted gratings; vi) a single photodetector on-chip is used to record the interferograms; vii) a compact multi-spiral waveguide approach is proposed to provide a compact footprint for the dFTS, despite the few-cm length of one MI arm; viii) the dFTS architecture applies to Ge-on-Si (GOS) chips for the mid infrared, as well as to SOI; ix) the dFT applies to other highresolution uses and x) most importantly, a spectrometer frequency-resolution of 1.0 to 1.5 GHz is predicted here for a custom design. In fairness to the prior approaches [1-3]. we note that they share the aforementioned features of compact spirals, one photodiode, GOS, and high resolution. However, our approach offers a factor-of-two reduction in the maximum arm length required.

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The paper is organized as follows. In the background discussion of Section II, the prior art is discussed in the context of the present dFTS. Section III presents the chip layout and our MI addressing technique. Signal reconstruction analysis is performed in Section IV, where several parametric simulations are performed for spectrometers based on both SOI and GOS platforms, operating at 1 GHz and at 1.5 GHz of resolution. Moreover, detailed analysis is presented in order to demonstrate the spectrum reconstruction of RF signals ranging from 15 to 100 GHz of bandwidth. The GOS chip is able to provide larger spectrometer bandwidth than the SOI chip due to germanium's ~3x larger TO coefficient. Finally, the conclusions are summarized in Section V.

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II. BACKGROUND DISCUSSION

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In the literature on prior-art on-chip FTSs, the principal approach taken has been to utilize a large number of progressively unbalanced Mach-Zehnder interferometers (MZIs) on a chip, such as 32 MZIs that are co-integrated on the same chip with 32 photodetectors, each PD dedicated to its MZI, resulting in a fairly complex chip [4-6]. Some alternatives to this multiple-MZI approach were reported recently [7-10]. The first method is to utilize only one MZI in which the two connecting arms are identical and quite long, ~ 34 mm for example [10]. There, a TO microheater is placed atop one of the two spiraled arms that then can provide a continuously variable, analog OPD between arms by modifying the waveguide effective index of only one arm (thermal expansion can come into play, too). The issue there is the rather limited repertoire of OPDs available (the small values produced) since the TO effect induces only one or two parts-per-thousand changes in index. The second approach takes a two-bus-coupled micro-ring resonator, a ring TO tuned, as the spectral input to a single balanced MZI having TO shifting of one of its arms. It is a fine approach but the limited OPD there gave somewhat limited FTS resolutions in the 0.14 to 0.47 nm range. An unusual and modern approach is the digital FTS invented in [1-3]. It is indeed a broadband spectrometer where a clever addressing method was adopted. A set of unequally joined 2 x 2 MZI cross-bar switches selects the effective length of each arm simultaneously in a compact arrangement where three switching stages offered 64 different OPDs. That work explored moderately high resolution but did not examine the specialized microwave-photonic RF application in which extremely high resolution is required. The present proposed 64-channel dFTS technique substitutes MI for MZI, uses reflection rather than transmission, avoids the use of any cross-bar switches, and relies instead upon TO shifting of a narrowband reflective grating, employing a temperature rise of 50K or less in mid-grating. The large OPDs that are feasible in the MI by coiling up its arms are beneficial for realizing extremely high resolution; but at the same time there is a penalty to be paid in the spectrometer bandwidth (BW). This observation bandwidth shrinks down to a very small value since $BW = N_{ch} \times \delta \lambda$ where N_{ch} is the channels number and $\delta \lambda$ is the resolution. This BW reduction is, however, acceptable for the microwave applications. We should point out an intrinsic disadvantage of the proposed architecture, which is the quadratic scaling law between N_{ch} the number of spectral channels and N_s the number of switches: $N_{ch} = (N_s/2)^2$. Indeed, for the 64 channel-dFTS, our device requires 16 WBGRs compared to 6 switches obtained in [2] where the scaling is exponential $N_{ch}=2^{Ns}$. Our quadratic scaling law can represent a bottleneck for applications in which a very large number of channels is required. Also, if we go outside of the radio frequency applications where lower resolution is accepted in order to cover a broad observation BW, then the grating BW will enter as a constraint that will limit the observation range and will prevent octave-spanning observations, for example.



Fig. 1. On-chip layout of a digital Fourier transform spectrometer using a thermo-optical Michelson grating interferometer.Each red square represents an optical absorber. In the picture the numbers "8" and "1" indicate that the spiral lengths are in the ratio 8:1

III. ON-CHIP SPECTROMETER ARCHITECTURE

The on-chip 64-channels spectrometer architecture is sketched in Fig. 1. The unknown-profile input signal is sent to the two arms of the Michelson interferometer by means of a 3 dB directional coupler. Each arm consists of 8 cascaded WBGRs separated by spiral waveguides of length $0.5 \times \Delta L$ and $4 \times \Delta L$ for the shorter and longer arm, respectively, where the value of ΔL is determined on the basis of the spectrometer resolution requirements and represents the separation between the center of two adjacent WBGR. Moreover, a $4 \times \Delta L$ long spiral waveguide at the input of the longer arm is required in order to generate 64 different OPDs in the range from ΔL to $64 \times \Delta L$. The WBGR elements are notch-reflection gratings that are implemented by inserting a phase-shifting segment within the grating. It is assumed here that this spectral profile can be easily shifted along the wavelength axis by means of a lowpower heater stripe atop the grating, in the same manner that we previously described for WBGRs deployed in the arms of Mach-Zehnder interferometer devices [11-13] for the functions of tunable optical filtering and switching. The spectrometer operation can be explained with the aid of Fig. 2, where the TO-programming is shown in detail. The wavelength of operation (purple dashed line) is λ_0 . At the rest condition, all TOs are switched OFF and all identical WBGR transmissions are aligned at the same wavelength λ_0 , as in Figs. 2(a) and 2(b). Under this condition the overall structure has no reflection and no signal is detected at the output of the directional coupler. When a particular WBGR is tuned to a different wavelength by turning its heater ON (a wavelength adequately separated from λ_0 to induce low cross-talk, i.e. CT, Fig. 2 (d)), then the light arriving at that spatial location is reflected, as presented in Figs. 2(e) and 2(f). This shift of spectral profile induces a particular round trip path that depends upon the line position of the WBGR affected by TO switching (see Ref. [14] for details). As a result of switching different TO pairs in the MI arms, 64 different OPDs can be selected in progressing steps of ΔL .

In this context according to [3] the spectrometer resolution can be estimated as:

$$\delta\lambda = \frac{\lambda_0^2}{n_g N_{ch} \Delta L} \tag{1}$$

where n_g is the group effective index; taken as 4.2395 for SOI and 4.6238 for GOS.



Fig. 2. Type-1 addressing of a TO-programmble waveguide optical "delay line arm" using notch-R WBGRs for the selection of any one of four optical lengths. Here λ_0 is the wavelength of operation: (a) initial unheated line; (b) unheated R profiles; (c) unheated T profiles; (d) TO selection of third-grating; (e) shift of R profile; (f) shift of T profile.

Turning again to the architecture of Fig. 1, the 3dB directional coupler performs the interference between the signal reflected from both MI arms. Thus, the interferogram for each TO combination is recorded at the detector output. In this sense, the intensity measured by the detector for an arbitrary input signal (represented by a column vector \mathbf{x} with n elements) is [3]:

$$\mathbf{y} = \mathbf{A}\mathbf{x} \tag{2}$$

where the interferogram y is a column vector with 64 elements, each gives the detector output at a particular TO combination. The ensemble of spectra forms a $64 \times n$ calibration matrix **A**. Each row of **A** represents a reflectance spectrum and contains *n* elements, the number of wavelength points in the scan. Each column corresponds to a discretely sampled interferogram and contains 64 elements. It is worth outlining that since x is an unknown signal, the interferogram vector y recorded to the detector output can be interpreted as the predictor to be used together with the matrix **A** to reconstruct the input signal spectrum by minimizing the associated L₁ and L₂ norms via elastic net r regression methods [15-16].

IV. NUMERICAL RESULTS

The goal of this section is to present the design for the onchip spectrometer using thermo-optical Michelson grating interferometer. In particular, we propose parametric simulations to evaluate the reconstruction quality, assuming different types of input signals. Then, the performance of the spectrometer system operating at 1550 nm in the SOI platform and at 2000 nm in the GOS platform is evaluated.

A. 64-96 GHz Spectrometer Bandwidth

The individual resonant structure used in the MI architecture is a cascade of *N* closely end-coupled waveguided Bragg grating resonators as described in detail in [11-13]. One constituent resonator of the overall WBGR is illustrated in Fig. 3(a), where the fundamental design parameters are indicated. Such *N*-combining allows for engineering of the spectral profile (such as side walls and bandwidth BW_g) of the *N*-coupled structure. The *N*-WBGR is realized in a single-mode wire waveguide as sketched in Fig. 3(b) and 3(c) for the SOI and GOS platforms, respectively. The unperturbed cross section is $W \times H = 450 \times 250$ nm, and $W \times H = 700 \times 500$ nm, for the single TE-mode SOI and GOS waveguides, respectively.



Fig. 3. (a) Top view of SOI strip waveguide showing the geometry of one phase-shifted Bragg-grating resonator that is used in a set of closely coupled resonators; (b) SOI waveguide cross section; (c) GOS waveguide cross section.

The Bragg grating sections are created by introducing along the nanowire, sidewall corrugations having width extension $W_t = 100$ nm. The period is chosen to be $\Lambda = 315$ nm and 273.65 nm in order to operate at the central wavelength λ_0 of 1550 nm and 2000 nm in the case of SOI and GOS, respectively. The separation between individual resonators is zero in our work. Hereafter, the length of the first Bragg resonator is given as $LB_1 = M \times A$, where M is the number of periods in the Bragg section of the first WBG. In addition, the lengths LB_i (i = 2...N) have been designed as a function of LB_1 in order to induce the Butterworth transmittivity response. Moreover, all simulations are performed using a mixed fullvectorial mathematical model based on the FEM, CMT and Transfer Matrix approaches (see Ref. [11] for details). Several parametric simulations indicate that the signal reconstruction improves greatly if the condition $BW_{e}\sim 2 BW_{s}$. We take this result as an important design rule for the dFTS. In this context, we consider two different WBGR structures, having N=3, M=20, $LB_1=6.3 \mu m$, $BW_p=130$ GHz and N=3, M=57, $LB_1=15.6$ μ m, BW_{e} =125.44 GHz, for the SOI and GOS platforms, respectively.

Having determined two representative notch-R gratings, Figs. 4 (a) and 4(b) show the WBGR transmittivity spectra for different values of the TO-induced refractive index change (Δn) and for SOI and GOS, respectively.

The plot of Fig. 4 indicates that by setting $\Delta n(SOI)$ =0.004 and $\Delta n(GOS)$ =0.009, a wavelength shift of 1.453 nm from λ_0 =1550 nm (*SOI*) with a CT=-27 dB and a (*GOS*) shift of 3.913 nm from λ_0 =2000 nm with CT =-37.72 dB can be recorded. Moreover, due to the silicon and germanium thermo-optic coefficient dn/dT=1.86×10⁻⁴ K⁻¹, and 5.8×10⁻⁴ K⁻¹ a local temperature change of $\Delta T \sim 21.5$, and 15.51 K are expected for the spectrometers based on SOI or GOS platform,

respectively. Note that a shift of 12.6 nm is feasible in GOS for $\Delta T = 50$ K.



Fig. 4. WBGR transmittivity spectrum for different values of Δn ; (a) SOI: W=450 nm, H=250 nm, N=3, M=20, W_i= 100 nm, and α_i =0.5 dB/cm. (b) GOS: W=700 nm, H=500 nm, N=3, M=57, W_i= 100 nm, and α_i =0.5 dB/cm.

Next, we examine the operation of our dFT spectrometer based on the thermo optical Michelson grating interferometer at both 1 GHz and 1.5 GHz of resolution (δf). In Table I we summarize the geometrical parameters of the MI spectrometer.

TABLE I GEOMETRICAL PARAMETERS OF THE MI SPECTROMETER				
	Spectrometer		Spectrometer	
	resolution:		resolution:	
	δλ=1 GHz		δλ=1.5 GHz	
	SOI	GOS	SOI	GOS
WBGR length: [µm]	40.77	57.87	40.77	57.87
⊿L [mm]	1.11	1.01	0.74	0.67
Short arm length [mm]	3.91	3.60	2.62	2.42
Long arm length [mm]	35.38	32.44	23.59	21.63

Table I shows that the GOS provides a ~ 30% reduction in the MI arms lengths. Let us now examine specifics about the total spectrometer size (footprint) and the spirals required. We consider the worst-case scenario that is represented by the SOI platform operating at 1 GHz of resolution where the 35.38 mm MI long-arm length must be accommodated. There, each spiral has a waveguide length of 4.26 mm including its two short connectors. We thus will examine 4-mm-length spirals in the long arm. For their construction, we shall take our cues from the experiments of [10] where each arm of their MZI consisted of a rectangular spiral having a footprint of about 0.25 mm ×1 mm for a 30.4 mm waveguide length, using 5 μ m waveguide spacing, and right-angle waveguide bends with a bend radius of 10 μ m. For our dFTS, this spiral compression factor implies an area of 0.033 mm² for our 4 mm spirals, which could for example, be a rect-spiral of 200 μ m \times 166 μ m footprint. For that reason, it is likely that the entire Fig. 1 dFTS could fit on a silicon chip of the order of 8 mm \times 4 mm for example.

The reflectivity spectra of the device for all 64 perturbations of the on/off TO combinations are plotted in Figs. 5(a) and 5(b), for SOI and GOS respectively, where the spectrometer resolution is 1 GHz.



Fig. 5. Reflectivity as a function of the number channel and the optical wavelength: (a) SOI: W=450 nm, H=250 nm, N=3, M=20, W_r = 100 nm, and α_i =0.5 dB/cm; (b) GOS: W=700 nm, H=500 nm, N=3, M=57, W_r = 100 nm, and α_i =0.5 dB/cm. The simulations are performed at 1 GHz of resolution.

In the simulations, we have assumed the corrugation width (W_l) , and the propagation loss coefficient (α_l) of 100 nm and 0.5 dB/cm, respectively. The WBGR shift spectrum is created by the TO-induced refractive index change of Δn =0.004 and 0.009 for SOI and GOS techological platform, respectively. Moreover, the TE polarization, specifically the TE₀₀ like fundamental optical mode, has been assumed in our analysis. In order to isolate thermally the passive spirals in Fig. 1 from the TO-perturbed gratings, an air trench can be etched underneath the short connecting waveguides going to the spirals. Thereby the spirals gain some thermal isolation from suspended connectors, as desired. Also, some air trenches can be etched in the over-cladding dielectric to add thermal isolation.

The ensemble of 64 reflectivity spectra shown in Fig. 5 represents the basis set for spectrum reconstruction based on elastic net regularized regression method.

To demonstrate the principle of behaviour of the MI spectrometer, we apply the reconstruction technique to two types of input signals: Lorentzian profiles with different linewidth, and generic polychromatic signals.



For the specific MI spectrometer based on the SOI platform, Figs. 6(a)-6(d) show the recostructed spectra for $\delta f=1$ GHz and 1.5 GHz, assuming in input Lorentzian signals having the FWHM (δf_{FWHM}) ranging from 15 to 70 GHz. Our simulations indicate that the device is able to reconstruct the input signal in its fundamental features such as shape and bandwidth. Moreover, the reconstruction quality is very high up to a FWHM value around 40 GHz. Unwanted ripples appear when the input signal presents a bandwidth approaching the spectrometer bandwidth ($BW_s= 64$ or 96 GHz). To test the reconstruction quality, we apply at the input of the SOI spectrometer an arbitrary input spectra having several dips and peaks. The results are plotted in Figs. 7(a)-7(c), confirming that a very high quality recostruction can be obtained for arbitrary input signal up to 40 GHz of bandwidth. Similar

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Fig. 6. Signal reconstruction for different input Lorentzian signals (red solid lines) (a) FWHM= 15 GHz; (b) FWHM= 25 GHz; (c) FWHM= 50 GHz; (d) FWHM= 70 GHz. The simulations are performed by considering:c64 channels, 1 GHz (dot) and 1.5 GHz (asterisk) of resolution in SOI platform.

Fig. 7. (a)-(c) Signal reconstruction for arbitrary input signals (red solid lines). The simulations are performed by considering: 64 channels, 1 GHz (dot) and 1.5 GHz (asterisk) of resolution in SOI platform.

systematic investigations have been performed for the

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spectrometer using a thermo-optical Michelson grating interferometer realized in the GOS platform.

The numerical results are condensed in Fig. 8, and lead to the same conclusions made for the SOI platform, although showing some discrepancies for the GOS realization at 1.5 GHz of resolution. It is worth outlining that the simulations of Fig. 8 have been performed for given geometrical parameters optimized at 1 GHz of resolution. Thus, the condition $BW_g \sim 2$ BW_s at 1.5 GHz of resolution is not satisfied, inducing some discrepancies in the signal recostruction.



Fig. 8. Signal reconstruction for arbitrary input signals (red solid lines). The simulations are performed by considering: 64 channels, 1 GHz (dot) and 1.5 GHz (asterisk) of resolution in GOS platform.

B. 243 GHz Spectrometer Bandwidth

In this sub-section we investigate the feasibility of reconstructing an RF signal with large bandwidth of 100 GHz. In this context we assume the architecture of Fig. 1 having a resolution δf =3.8 GHz corresponding to a BW_s =243.2 GHz. Thus, an RF BW up to ~200 GHz could actually be accepted. The relationship $BW_{g} \sim 2 BW_{s}$ implies that only the GOS platform is to be used for the 100-200 GHz RF BW dFTS. This happens because large values of BW_g require large TO tuning in order to adequately separate the center WBGR wavelength from λ_0 . Due to the ~3x larger thermo-optic coefficient, germanium can guarantee a large value of Δn but with a moderate local heating. Therefore in the following analysis, we consider the WBGR structures, having N=3, M=30, $LB_1=8.2\mu m$, and then $BW_{a}=500.6$ GHz. The value $\Delta n(GOS)=0.018$ has been assumed to induce a wavelength shift of about 7.884 nm (589 GHz) with CT =-17 dB. Moreover a local temperature change of $\Delta T \sim 31$ K is expected.

Looking at the architecture of Fig. 1, we estimate ΔL = 0.267 mm, yielding GOS MI arm lengths of 8.53 mm and 0.99 mm, respectively.

In this context, taking a "wide" arbitrary RF band, Fig. 9(a) shows the reflectivity spectra of the GOS dFTS for all 64 perturbations of the on/off TO combinations, assuming the spectrometer resolution is 3.8 GHz. On the basis of the interferograms plotted in Fig. 9(a), the retrieved signal is shown in Fig. 9(b) indicating that an arbitrary input signal with a bandwidth around 100 GHz can be reconstructed with a good quality. Moreover, Fig. 9 (b) shows the realistic scenario

in which phase errors take place as induced by an error ($E_{\Delta L}$) in the designed value ΔL . In the worst-case scenario, we have assumed that all the spiral waveguides are affected by the aforementioned errors. The simulations reveal that the main part of the spectrum is accurately retrieved up to $E_{\Delta L}=10\%$, with a weak broadening around the secondary peak at Δf =-50 GHz. However, this plot also demonstrates degradation of the retrieved spectrum for $E_{\Delta L}>15\%$ as result of the presence of unwanted virtual artefacts (spikes).



Fig. 9. (a) Reflectivity as a function of the number channel and the optical wavelength; (b) Signal reconstruction for arbitrary input signals (red solid lines); dot: $\delta f = 3.8$ GHz, $E_{\Delta L}=0\%$; square: $\delta f = 3.8$ GHz, $E_{\Delta L}=10\%$; asterisk: $\delta f = 3.8$ GHz, $E_{\Delta L}=15\%$; The simulations are performed by considering: 64 channels, in GOS platform: *W*=700 nm, *H*=500 nm, *N*=3, *M*=30, *W_t*= 100 nm, and α_i =0.5 dB/cm.

The dFTS chip is in an environment with an ambient temperature, and realistically there will be small fluctuations in that ambient. This then raises the question of how the spiral's "performance" will be modified by minor changes in the spiral waveguide's effective index induced by chip temperature changes. We have examined this question, and proceeding in a manner similar to that taken in Fig. 9 (b), we speculate that thermally induced optical-phase errors of up to 10% on each waveguide spiral can be accepted with no strong effects upon the retrieved spectrum. For the case of larger phase errors, this requires the technique of calibration (see Ref. [18]) in order to eliminate degradation of the retrieved spectrum. As mentioned above, thermal isolation techniques are available. Generally, we estimate that added thermal controllers are not required for the spirals.

The GOS dFTS is expected to operate well over the 2 to 16 μ m wavelength range because the GOS-MI waveguided circuit is quite transparent over that range, and because the TO

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coefficient stays about the same over that range. For operation

at any central wavelength λ_0 greater than 2 µm and less than 16 μ m, the strip waveguide $W \times H$ dimensions and the grating tooth extensions W_t would all be scaled up appropriately from their 2 μ m values. Taking Δ T~ 50K as an upper limit, which gives $\Delta n = 0.029$, we then calculated the wavelength-shift of the grating profile $\Delta \lambda_{sh}$ at values of λ_0 at the low end and at the high end of the range. We found that the shifted profile experienced -17 dB of optical crosstalk when we took BW_g as 72% of $\Delta \lambda_{sh}$. Using that BW_g and taking $BW_g \sim 2 BW_s$, we then determined that $BW_s = 0.22\%$ of λ_0 for any λ_0 in the GOS transparency range. Considering both SOI and GOS platforms, we see that all resonant structures in the MI arms have nanometer-scale features that require high precision in the fabrication. In practice, there will always be fabrication errors related to dimensional inaccuracies in the WBGR grating. If dimensional errors $\Delta \Lambda$ are made in fabricating the period, deviation from λ_0 by an amount, $\Delta \lambda_{tol}$, occurs. In this context quantitative estimations are proposed in our recent works [11-12]. Generally speaking, the way to minimize fabrication errors is to manufacture the chip in an advanced, high resolution, CMOS foundry. Even so, a few WBGR errors would remain, however, their effect can be minimized. The approaches available to do this were discussed in [17]. The techniques include employing micron-scale direct-current TO heaters on the arms to "trim" their response on a constant basis, and/or to deposit atomic-layer films on the arms to offer permanent trimming of any imbalances.

V. CONCLUSIONS

In this paper, a novel, manufacturable on-chip thermo-optical Michelson grating interferometer for Fourier spectral reconstruction application is proposed and analyzed theoretically. The digitally addressed chip consists of two different-length tunable delay lines, operating in reflection mode. Each delay line is based on notch-reflection gratings that are implemented by inserting a phase-shifting segment within the grating in order to realize a resonatnt peak in transmission. Waveguide Bragg grating resonators consisting of N closely coupled resonators are used here as active devices. The N value and the cavity grating lengths have been chosen to satisfy the Butterworth filter technique, resulting here in a filter profile with high peak transmission, and a bandwidth twice that of the spectrometer bandwidth according to our optimization procedure. The 2x design rule is related to bandwidth narrowing effects in each delay line. Grating sections are constructed by extending numerous uniform "teeth" laterally beyond the width of the TE single-mode strip waveguide. The unperturbed waveguide cross sections of 450×250 nm and 700×500 nm have been considered for silicon on insulator and germanium on silicon technological platforms, respectively. The device generates 64 selectable optical path differences between the MI arms, by tuning only one particular resonator in each arm using low-power TO. A single photodetector on-chip is used to record these 64 interferograms. On the basis of these interferograms, the RF spectrum reconstruction has been investigated for both Lorentzian and arbitrary input signals. The simulations have demonstrated that high quality reconstructions are feasible for

RF-modulated input bandwidth up to 40 GHz, by assuming spectrometer resolutions of 1 GHz or 1.5 GHz. In this context, the larger WBGR spacing in the longer MI arm has been estimated as 7.04 mm and 4.68 mm for SOI (1.55 µm) and GOS (2 μ m), respectively. Thus, spiral waveguide-connecting structures have been assumed between adjacent WBGRs. Moreover, spectrum recostruction of an input RF signal with 100 GHz of bandwidth (well within the BWs of 243 GHz) has been obtained in the GOS platform assuming a spectrometer resolution of 3.8 GHz, and a local temperture change of about 31 K. Regarding chip losses, we find that as the optical spectrum travels from chip input to photodiode, it experiences a loss comprised of 6 dB directional coupler loss (3 dB worse than in [2]), plus a variable loss due to traversal of the delay lines. In the worst case, the variable loss is 14 IL_{g} where IL_{g} is the transmission loss of one WBGR. An overall maximum loss of about 10.2 dB is estimated for the case where $IL_{\rho} = 0.3$ dB. Moreover, in the worst-case scenario (for the 64th channel), we record an extinction-ratio reduction from 24.7 dB to 16.52 dB for the propagation losses ranging from 0.25 dB/cm to 3 dB/cm. Beneficially, in this range, simulations indicate that the impact upon the spectrum reconstruction is negligible. In addition, if we consider the results of differential attenuation between the two arms of the MI [19], we do find unwanted oscillatory features with unphysical negative values that take place in the peripheral spectral regions. However, despite those effects, the main part of the spectral reconstruction is still preserved.

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